



Residue Monitoring

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The Invention

A residue management system or method can be implemented for an agricultural harvester that includes a residue processing system. A sensor arrangement can be in communication with one or more components of the residue processing system. The sensor arrangement can be configured to measure indicators of a mass flow rate of the crop residue through the crop residue system across a width of a stream of the crop residue.

Tech Fields

- [Animals, Agriculture & Food : General agriculture technologies](#)

For current licensing status, please contact Emily Bauer at emily@warf.org or 608-960-9842